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INVENTOR'S STATEMENT OF CONTRIBUTION AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT

APPLICANT: Christian LAURENT-LUND  
 SERIAL NO.: 10/516,527  
 FILING DATE: June 6, 2005

GROUP ART UNIT: 2874  
 ATTY. DOCKET NO.: P67953US1  
 TODAY'S DATE: October 25, 2005

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### U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE (If Appropriate)
/SP/	AA	4,781,424	11/01/88	Kawachi et al.			
	AB	5,058,978	10/22/91	Kondoh et al.			
	AC	5,629,999	05/13/97	Henry et al.			
	AD	5,745,618	04/28/98	Li			
	AE	5,745,619	04/28/98	Li et al.			
	AF	5,757,995	05/26/98	Chen et al.			
	AG	6,044,192	03/28/00	Grant et al.			

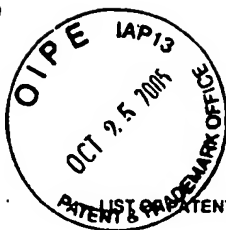
### FOREIGN PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	Translation	
							(Yes)	(No)
/SP/	AH	EP 0 424 913 A2	05/02/91	EP				Equiv.
	AI	EP 0 731 367 A2	09/11/96	EP				Equiv.
	AJ	WO 97/32228	09/04/97	WIPO				Abstract
	AK	EP 0 811 860 A2	12/10/97	EP				Equiv.
	AL	JP 11 271 551 A2	10/08/99	JP				Abstract
	AM	JP 2000075 327 A2	03/14/00	JP				Abstract
	AN	WO 00/48024	08/17/00	WIPO				

### OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

/SP/	AO	H. Nishihara et al., "Optical Integrated Circuits", McGraw-Hill, 1989
	AP	J.D. Love et al., "Highly broadband Buried Channel Couplers", Electronic Letters, Vol. 30, No. 22, pps. 1853-1855, October 1994
	AQ	A. Takagi et al., Broadband Silica-Based Optical Waveguide Coupler with Asymmetric Structure", Electronic Letters, Vol. 26, No. 2, pps. 132-133, January 1990
	AR	M. Kawachi., Silica Waveguides on Silicon and Their Application to Integrated-Optic Components", Optical and Quantum Electronics 22, pps. 391-416, 1990
	AS	C. Laurent-Lund et al., "PECVD Grown Multiple Core Planar Waveguides. . .", IEEE Photonics Technology Letters, Vol. 10, No. 10, October 1998, pps. 1431-1433
	AT	R.A. Levy et al., "Reflow Mechanisms of Contact Vias in VLSI Processing", J. Electrochemical Society, Vol. 133, No. 7, pps 1417-1424
EXAMINER /Sung Pak/		DATE CONSIDERED 04/09/2007

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant(s).



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LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT

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*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE (If Appropriate)
/SP/	BA	6,195,481	02/27/01	Nakajima et al.			
/SP/	BB	6,212,307	04/03/01	Labeye et al.			
/SP/	BC	2003/0165295 A1	09/04/03	Doerr			
/SP/	BD	6,621,971	09/16/03	Orignac et al.			
	BE						
	BF						
	BG						

### FOREIGN PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	Translation	
							(Yes)	(No)
/SP/	BH	EP 1 045 263	10/18/00	EP				Equiv.
/SP/	BI	WO 01/90791	11/29/01	WIPO				Abstract
/SP/	BJ	WO 02/088791 A2	11/07/02	WIPO				
	BK							
	BL							
	BM							
	BN							

### OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

	BO	
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